

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Yosuke INOMATA, et al.

Serial No: 10/650,504

Conf. No.: 6973

Filed: August 27, 2003

For: Dry Etching Apparatus, Dry  
Etching Method, and Plate and  
Tray Used Therein

Art Unit: 1765

Examiner: Anita Karen Alanko

I hereby certify that this correspondence  
is being transmitted via electronic filing  
to:

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450 on

April 12, 2007

Date of Deposit

Diane Zywn

Name

*Diane Zywn* 04/12/07

Signature

Date

**PETITION FOR EXTENSION OF TIME**

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a one-month extension of time extending to April 15, 2007, the period for response to the Final Office Action dated December 15, 2006. Please charge the fee of \$120 for this extension to Deposit Account No. 50-1314. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By:

*Lawrence J. McClure*

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Date: April 12, 2007

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